

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Deok-kee Kim et al.

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Examiner: A. Arena

For: TOP-OXIDE-EARLY PROCESS AND ARRAY TOP OXIDE
PLANARIZATION

Commissioner for Patents
United States Patent and Trademark Office
P. O. Box 1450
Alexandria, Virginia 22313-1450

REQUEST FOR RECONSIDERATION UNDER 37 C. F. R. §1.116

Sir:

In response to the Office Action mailed April 3,
2007, please reconsider the above-identified application
in view of the following remarks.

No amendments to the specification are
presented in this paper.

A full listing of the claims begins on page 2
of this paper.

Remarks begin on page 7 of this paper.

Approved for Entry
A.D.A.
14 June 2007